DECLARATION FOR PATENT APPLICATION

As a below named inventor, I declare that my residence, post office address and citizenship are as stated below above my name; I believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

NITRIDE SEMICONDUCTOR DEVICE

the specification of which (check applicable box(es	3)).
[X] is attached hereto.	as United States Application No. or PCT International Application
[] was filed on	
No.	
[] and was amended on	the second secon
I hereby state that I have reviewed and understand	d the contents of the above-identified specification, including the claims,

as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or 365(b) of any foreign application(s) for patent or inventor's certificate, or 35 U.S.C. 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed:

Japanese Patent Application No. 7-287189, filed November 6, 1995	Priority Claimed
Japanese Fatent Application 10. 7 200070 Stad November 24 1006	Priority Claimed
Japanese Patent Application No. 7-305279, filed November 24, 1995	•
Japanese Patent Application No. 7-305280, filed November 24, 1995	Priority Claimed
Japanese Patent Application No. 7-305281, filed November 24, 1995	Priority Claimed
Japanese Patent Application No. 7-317850, filed December 6, 1995	Priority Claimed
Japanese Patent Application No. 7-332056, filed December 20, 1995	Priority Claimed
Japanese Patent Application No. 8-186339, filed July 16, 1996	Priority Claimed
Japanese Patent Application No. 8-228147, filed August 29, 1996	Priority Claimed
supuration of the same of the	

I hereby claim the benefit under 35 U.S.C. 119(e) of any United States provisional application(s) listed below.

I hereby claim the benefit under 35 U.S.C. 120 of any United States application(s) or 35 U.S.C. 365(c) of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application or PCT International application in the manner provided by the first paragraph of 35 U.S.C. 112, I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR 1.56, which became available between the filing date of the prior application and the national or PCT international filing date of this application.

I hereby appoint as my attorneys, with full powers of substitution and revocation, to prosecute this application and transact all business in the Patent and Trademark Office connected therewith: Arthur R. Crawford (Reg. No. 25,327), Larry S. Nixon (Reg. No. 25,640), Robert A. Vanderhye (Reg. No. 27,076), James T. Hosmer (Reg. No. 30,184), Robert W. Faris (Reg. No. 31,352), Richard G. Besha (Reg. No. 22,770), Mark E. Nusbaum (Reg. No. 32,348) and Michael J. Keenan (Reg. No. 32,106), each of whose address is 8th Floor, 1100 North Glebe Road, Arlington, Virginia 22201-4714, or any one of them, and request that correspondence be directed to Nixon & Vanderhye P.C.,8th Floor, 1100 North Glebe Road, Arlington, Virginia 22201-4714.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Meline

Post Office Address: c/o NICHIA CHEMICAL INDUSTRIES LTD., 491-100, Oka, Kaminaka-cho, Anan-shi,

Tokushima-ken, Japan Residence Address: Tokushima-shi,

Tokushima-ken, Japan

Country of Citizenship: Japan

Late: October 29, 1996

Shuii Nakamura

[2nd Inventor]

Post Office Address: c/o NICHIA CHEMICAL INDUSTRIES LTD., 491-100, Oka, Kaminaka-cho, Anan-shi,

Tokushima-ken, Japan

Residence Address: Tokushima-shi,

Tokushima-ken, Japan

untry of Citizenship: Japan

Date: October 29, 1996

Shinichi Nagahama

[3rd Inventor]

Post Office Address: c/o NICHIA CHEMICAL INDUSTRIES LTD., 491-100, Oka, Kaminaka-cho, Anan-shi,

Tokushima-ken, Japan

Residence Address: Komatsushima-shi,

Tokushima-ken, Japan

Country of Citizenship: Japan

Date: October 29, 1996

Naruhito Iwasa